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**BOX ISSUE FEE**  
PATENT  
1248-0673P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Yutaka TAKAFUJI, et al. Conf. No.: 4125  
Appl. No.: 10/668,186 Group: 2813  
Filed: September 24, 2003 Examiner: MENZ, Laura Mary  
For: SINGLE-CRYSTAL SILICON SUBSTRATE, SOI  
SUBSTRATE, SEMICONDUCTOR DEVICE, DISPLAY  
DEVICE AND MANUFACTURING METHOD OF  
SEMICONDUCTOR DEVICE

LETTER

**BOX ISSUE FEE**

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

Attached hereto please find a Form PTO-SB08 listing references which were cited in a Japanese Office Action mailed October 28, 2008.

Applicant respectfully requests that the attached documents be placed in the application file pursuant to MPEP § 609.04(b).

If the Examiner has any questions concerning this application, the Examiner is requested to contact Robert W. Downs, Reg. No. 48,222 at (703) 205-8000 in the Washington, DC area.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By Robert Down # 48222  
Charles Gorenstein  
Reg. No. 29,271

CG/RWD:cb

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Attachments: Form SB08